

<b>Notice of References Cited</b>			Application No. <b>09/336,126</b>		Applicant(s) <b>Ren et al.</b>	
			Examiner <b>Mike Miggins</b>		Group Art Unit <b>1772</b>	Page 1 of 1

  

U.S. PATENT DOCUMENTS						
*	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	
X	A	5,346,683	Green et al.	423	447.2	
X	B	5,457,343	Ajayan et al.	257	734	
X	C	5,726,524	Debe	313	309	
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	F					
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FOREIGN PATENT DOCUMENTS						
*	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
	N					
	O					
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	S					
	T					

  

NON-PATENT DOCUMENTS		
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X	U Chen et al., "Well-aligned Graphitic Nanofibers Synthesized by Plasma-assisted Chemical Vapor Deposition," Chemical Physics Letters 272: 178-182	1997
X	V Chen et al., "Field Emission from Aligned High-density Graphitic Nanofibers," Applied Physics Letters 73(15):2119-2121	1998
X	W Chen et al., "Plasma-induced Low Temperature Growth of Graphitic Nanofibers on Nickel Substrates," Journal of Crystal Growth 193:342-346	1998
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\* A copy of this reference is not being furnished with this Office action.  
(See Manual of Patent Examining Procedure, Section 707.05(a).)